

Search Notes 	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/750,027	PEDERSON, JOHN C.
	Examiner Benjamin C. Lee	Art Unit 2632

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
340	815.45	11/30/2005	<i>RJN</i>
	691.1		
	425.5	↓	↓